

MPG Halbleiterlabor Project Review 2022

Wednesday, 14 December 2022

Technology: I - Lecture Hall (15:15 - 16:30)

-Conveners: Florian Schopper

time	[id] title	presenter
15:15	[1] Introduction	NINKOVIC, Jelena
15:30	[2] Lithography	LEHMANN, Raik
16:00	[3] High Temperature processes	SCHALLER, Gerhard

Technology: II - Lecture Hall (17:00 - 18:30)

-Conveners: Gerhard Schaller

time	[id] title	presenter
17:00	[4] Wet processes - cleaning	SOYER, Martin
17:30	[5] Wet processes - etching	LEHMANN, Raik
18:00	[6] Implanter - Sputter	MATIASKE, Mark

Thursday, 15 December 2022

Technology: III - Lecture Hall (09:00 - 10:30)

-Conveners: Raik Lehmann

time	[id] title	presenter
09:00	[7] Plasma etching - status and plans for Garching	SCHOPPER, Florian
09:30	[8] Inspection tools	ZIRR, Christian
10:00	[9] Application lab	ANDRICEK, Laci

Technology: IV - Lecture Hall (11:00 - 12:30)

-Conveners: Laci Andricek

time	[id] title	presenter
11:00	[10] Copper line	LIEMANN, Gerhard
11:30	[11] Vertical interconnection	KRIVOKUCA, Silvia
12:00	[12] Bonding	MIESSNER, Danilo

Technology: V - Lecture Hall (14:00 - 15:30)

-Conveners: Mark Matiaske

time	[id] title	presenter
14:00	[13] Laser cutters	MAYATSKA, Alona
14:30	[14] Ramp-up technology sequence and projects	SCHOPPER, Florian SCHALLER, Gerhard